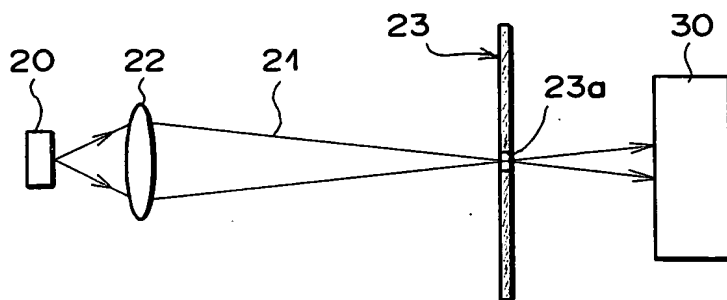
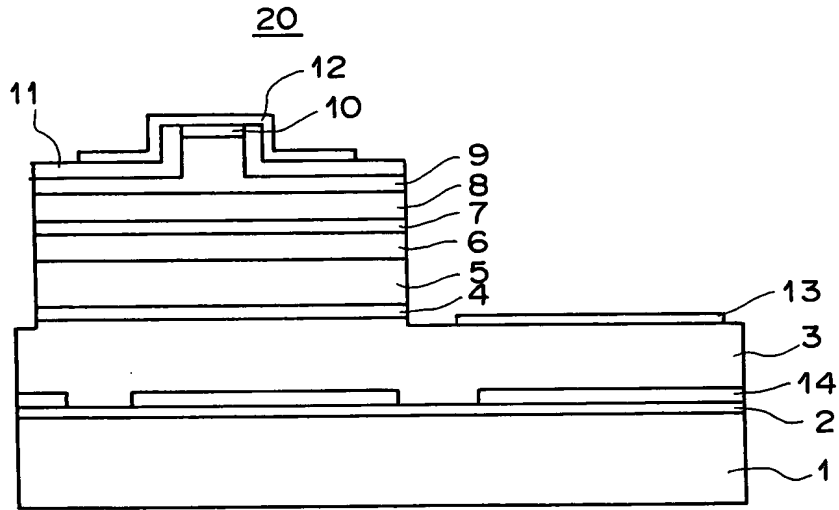


F I G . 1



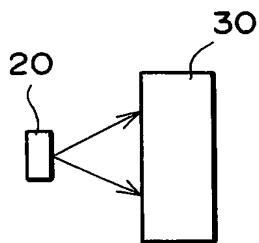
203270 35095007

F I G . 2

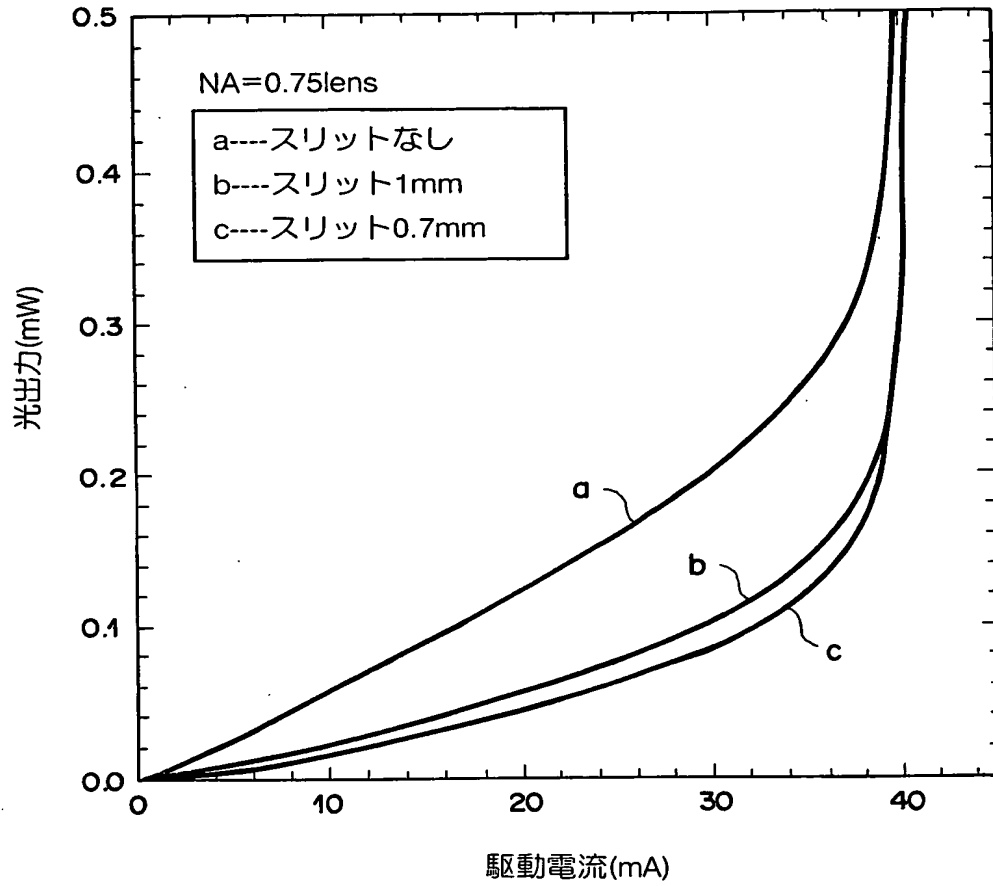


200270 82095001

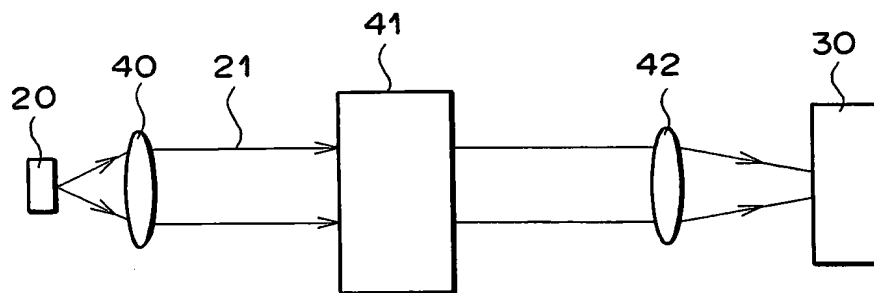
F I G . 3



F I G . 4

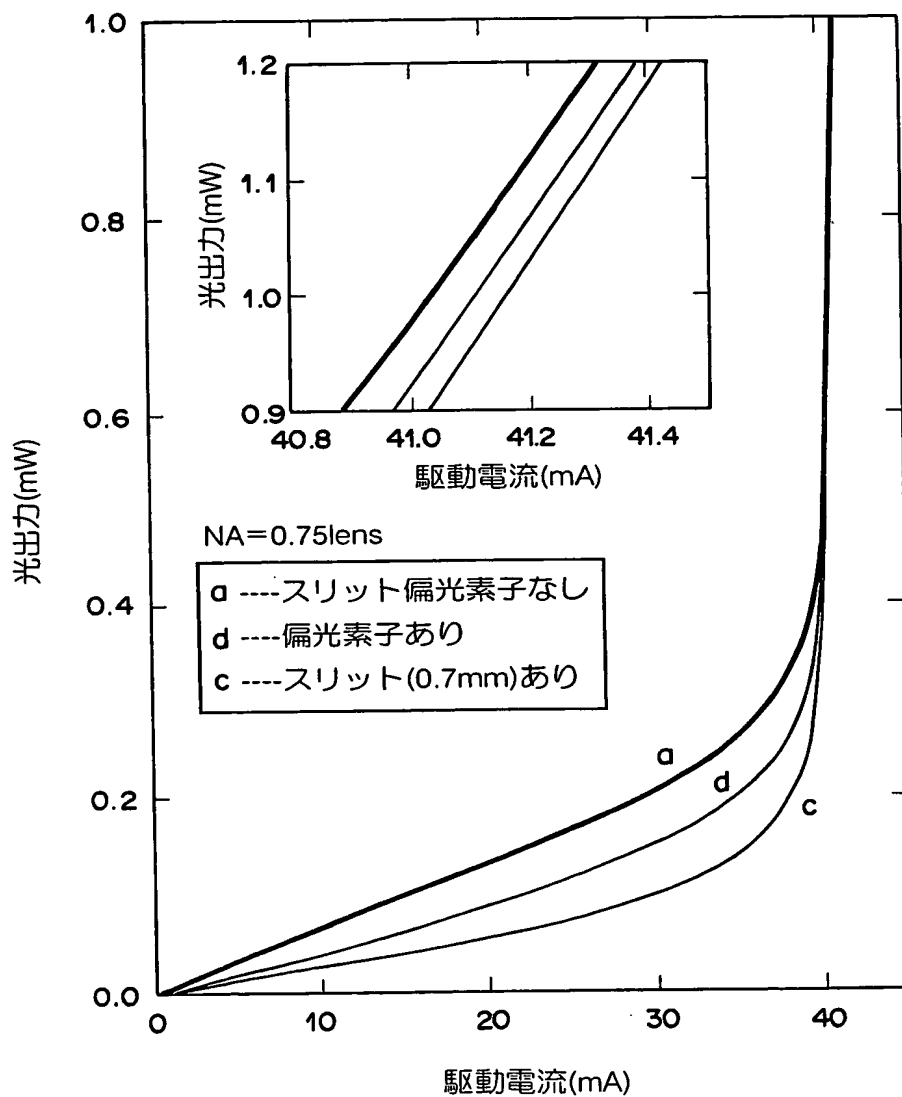


F I G . 5

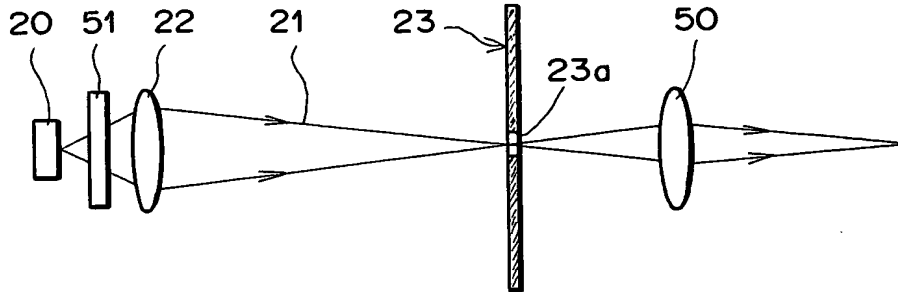


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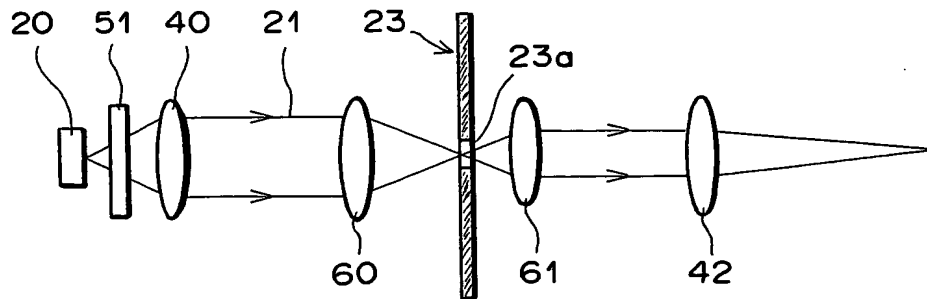
FIG. 6



F I G . 7

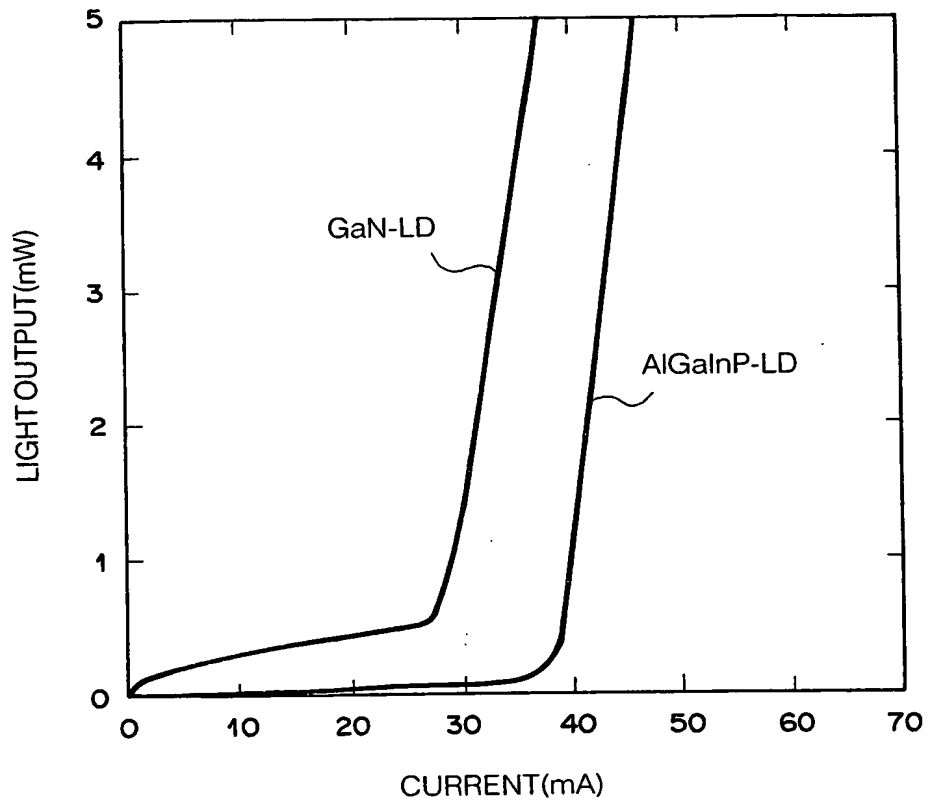


F I G . 8



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F I G . 9



F I G . 10

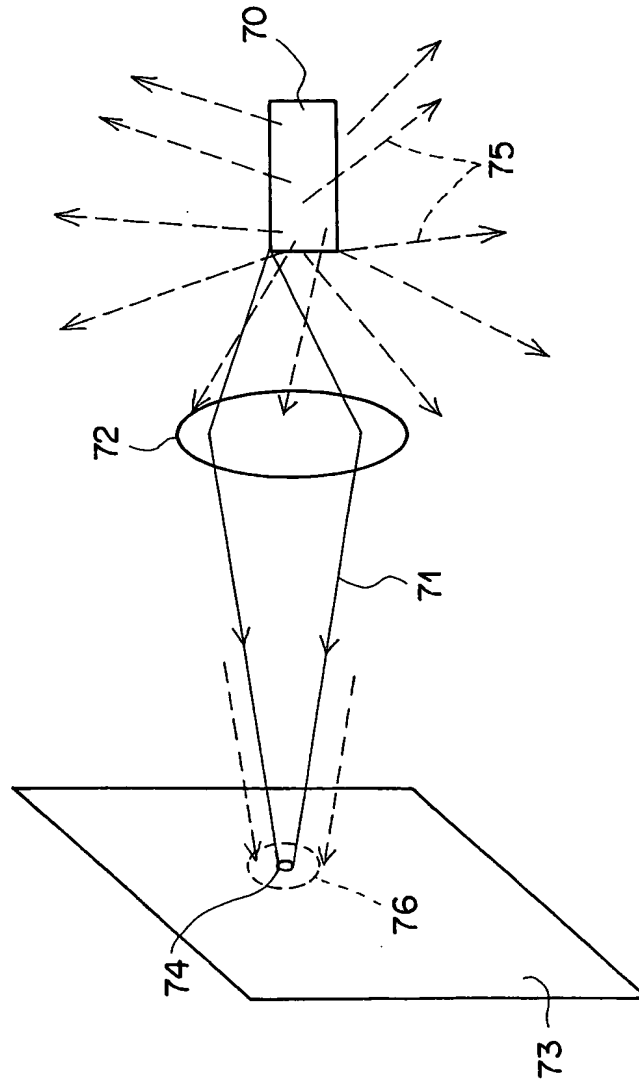


FIG.11

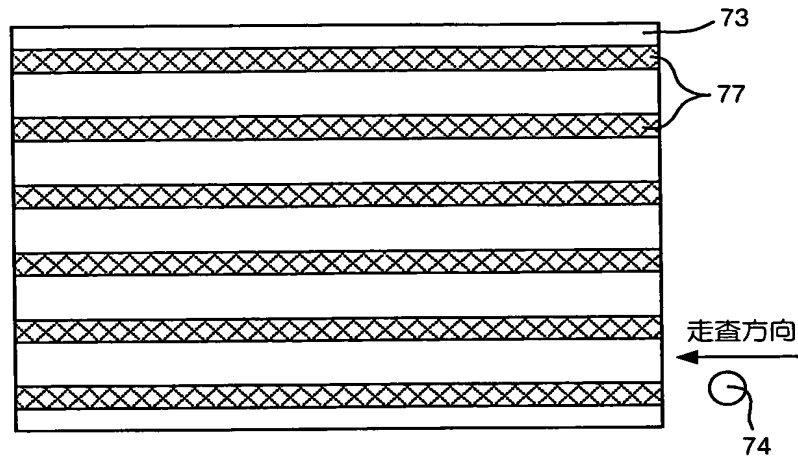
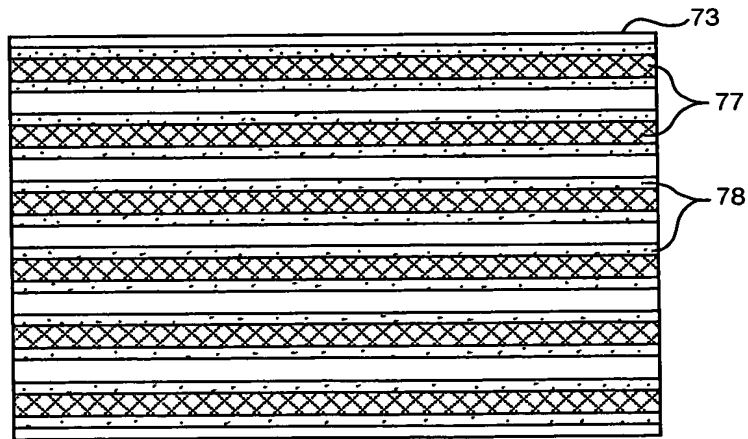


FIG.12



F I G . 1 3

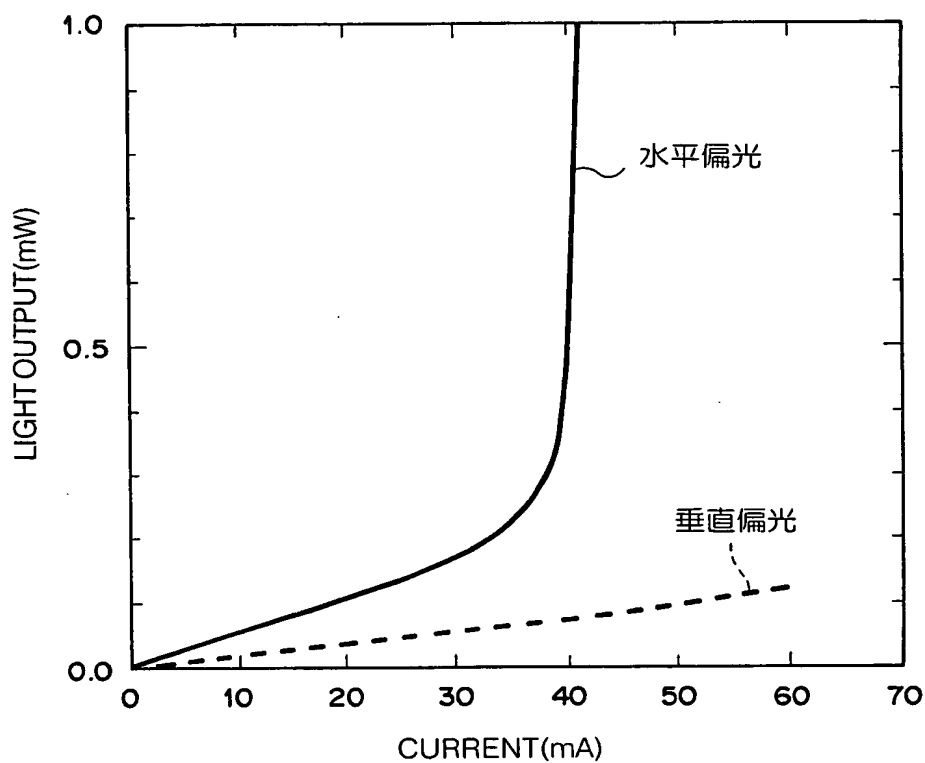
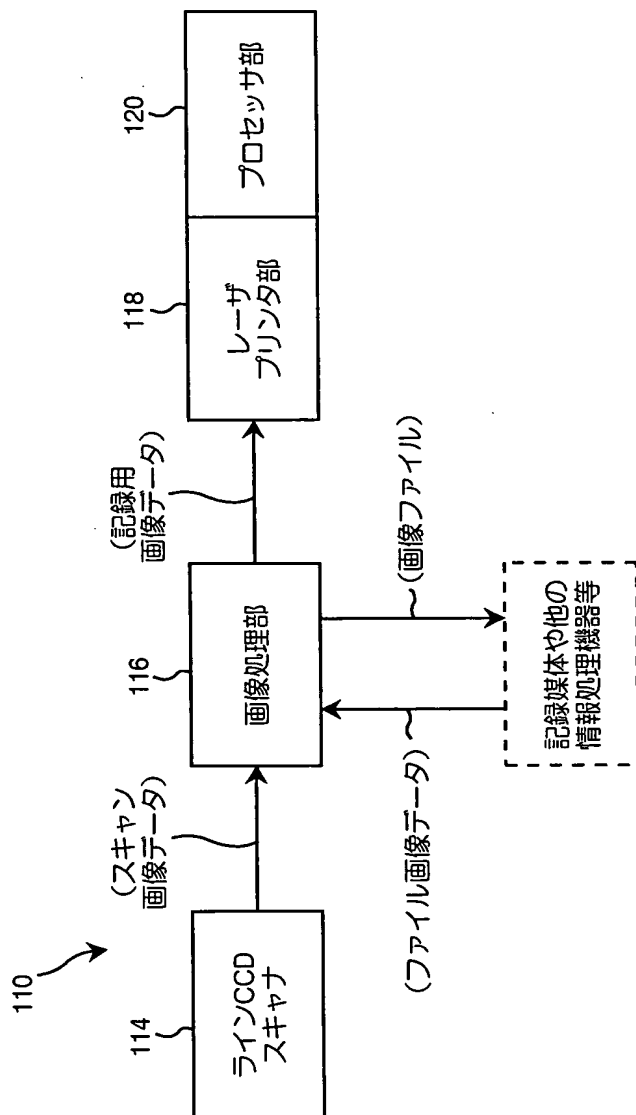
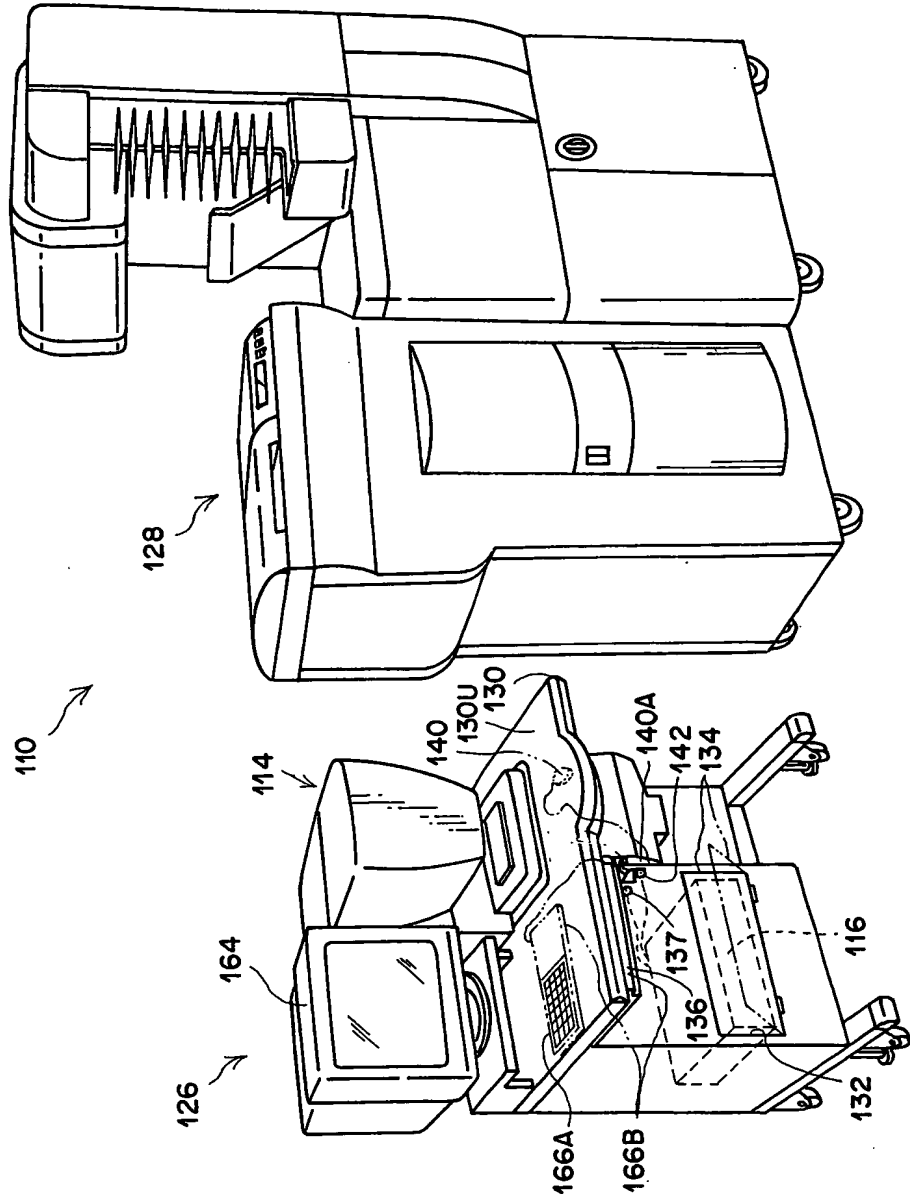


FIG. 14



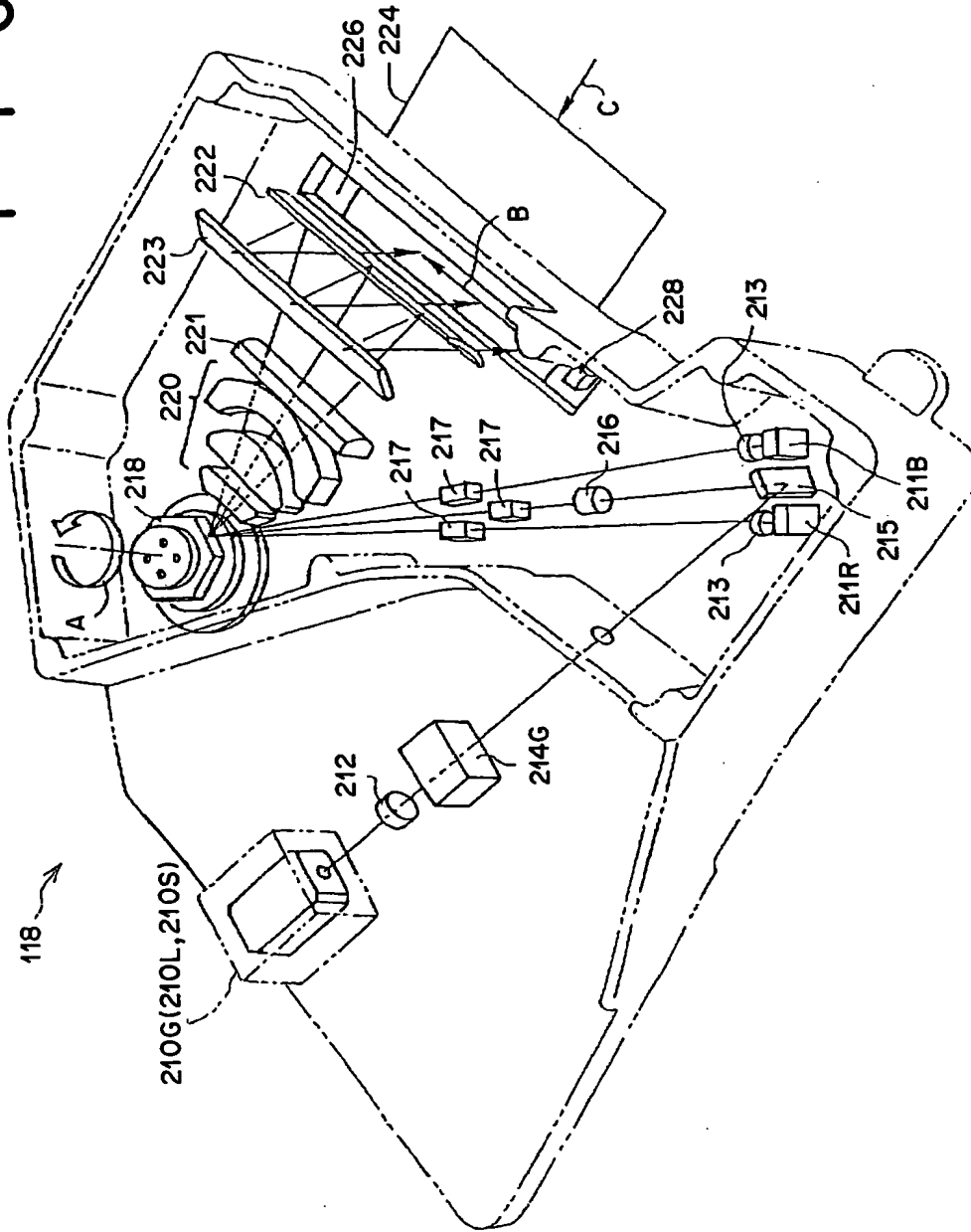
203210" 8E09500T

F I G . 15



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A LIGHT SOURCE APPARATUS EQUIPPED WITH
A GaN TYPE SEMICONDUCTOR LASER, ...
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FIG. 16



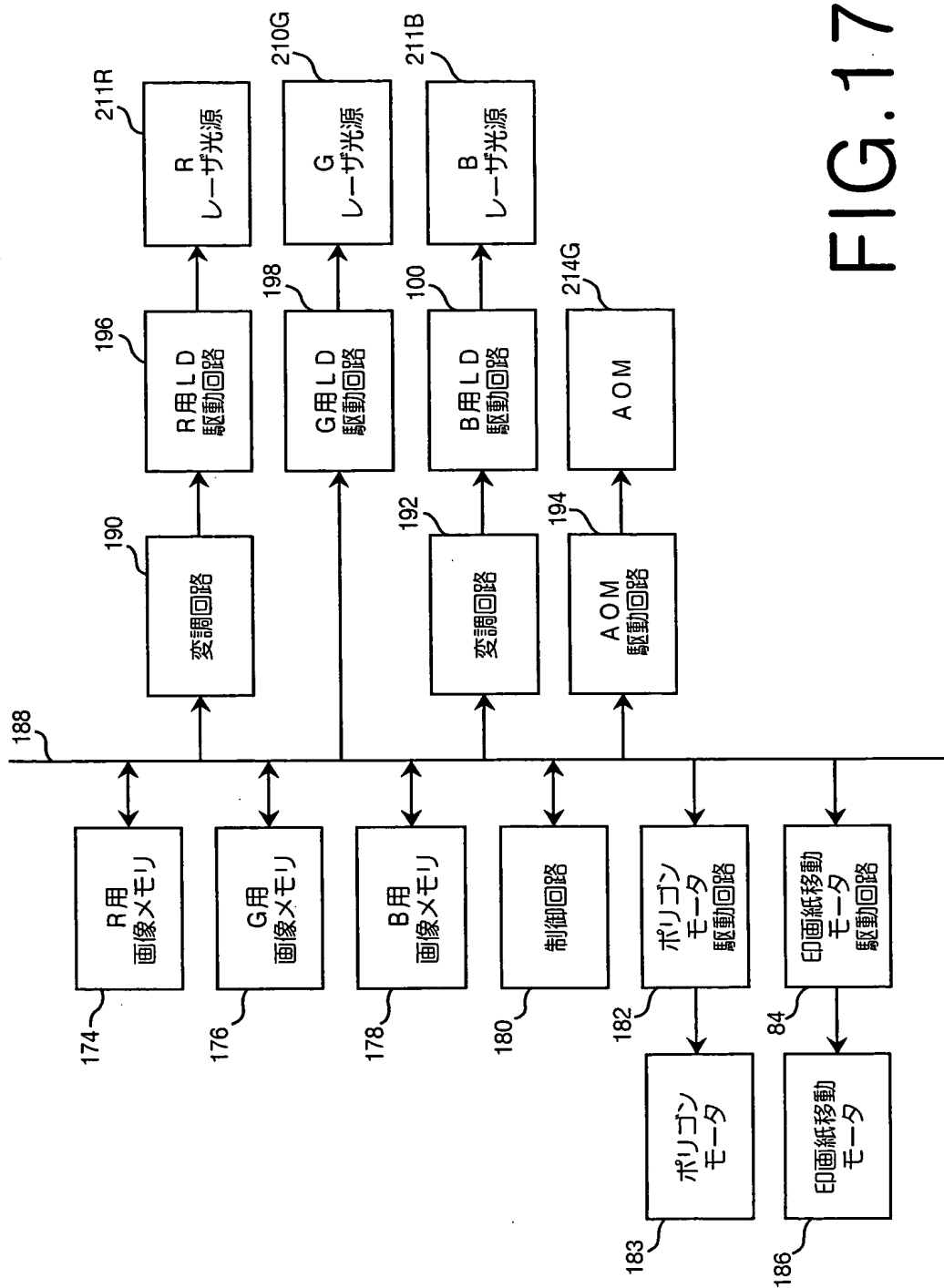


FIG.17